

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION NO. 09/677,781

MANABE et al.

Appln. No.: 09/677,781

Filed: October 2, 2000

Group Art Unit: 2812

Examiner: S. Mulpuri

Title: A METHOD FOR MANUFACTURING A GALLIUM NITRIDE GROUP
COMPOUND SEMICONDUCTOR

November 28, 2001

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INFORMATION DISCLOSURE STATEMENT

Request is hereby made under Rule 97(c) for consideration of the following IDS for which the requisite \$180 fee under Rule 17(p) is enclosed. Should that fee be missing or inadequate please charge the deficiency to our Deposit Account No. 03-3975 under Order No. 31317/273686.

Japanese Patent No. 59-228776 (Ref. KR) was previously cited in the Information Disclosure Statement of October 2, 2000. Applicants' submit herewith a full English translation.

This IDS is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

Respectfully submitted,
PILLSBURY WINTHROP LLP



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Enclosures: Form PTO-1449
Copy of references cited thereon